

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Klaus Leitner
Application No. : 10/525,993
Filing Date : February 28, 2005
For : SPUTTERING CATHODE, PRODUCTION METHOD AND
CORRESPONDING CATHODE
Examiner : Jason Berman
Art Unit : 1795
Confirmation No. : 2830

**6 Pages
Via EFS
Mail Stop Amendment
Attn: Examiner Stigell
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450**

ELECTION

Sir:

In response to the restriction requirement dated July 17, 2008, please take note of the following.